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| <b>FORM HDP-1449 (Based on Form PTO-1449)</b><br><br><b>PATENT AND TRADEMARK OFFICE</b><br><b>INFORMATION DISCLOSURE CITATION</b><br>(Use several sheets if necessary)<br><br>Sheet 1 of 1 | <b>ATTORNEY DOCKET NO.</b> | <b>SERIAL NO.</b> |
|  | 9319S-000617               | 10/760,176        |
|  | <b>APPLICANT</b>           |                   |
|  | Reiko WACHI                |                   |
|  | <b>FILING DATE</b>         | <b>GROUP</b>      |
| January 16, 2004   | 2811                       |                   |

| U.S. PATENT DOCUMENTS |                     |                 |            |       |                 |                              |
|-----------------------|---------------------|-----------------|------------|-------|-----------------|------------------------------|
| Ref. Desig.           | Examiner's Initials | Document Number | Date       | Name  | Class/ Subclass | (If appropriate) Filing Date |
| 1.                    |                     | 2002-0063834    | 03-12-1841 | Rider |                 |                              |

| FOREIGN PATENT DOCUMENTS |                     |                 |            |         |                 |                         |
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| Ref. Desig.              | Examiner's Initials | Document Number | Date       | Country | Class/ Subclass | Translation *<br>Yes No |
| 1.                       |                     | 2002-268200     | 09-18-2002 | Japan   |                 | X                       |
| 2.                       |                     | 08-321025       | 12-03-1996 | Japan   |                 | X                       |

| OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.) |                     |   |
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| 1.   |                     | Examination result issued in corresponding Chinese application. |

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| Examiner: | Date Considered: |
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